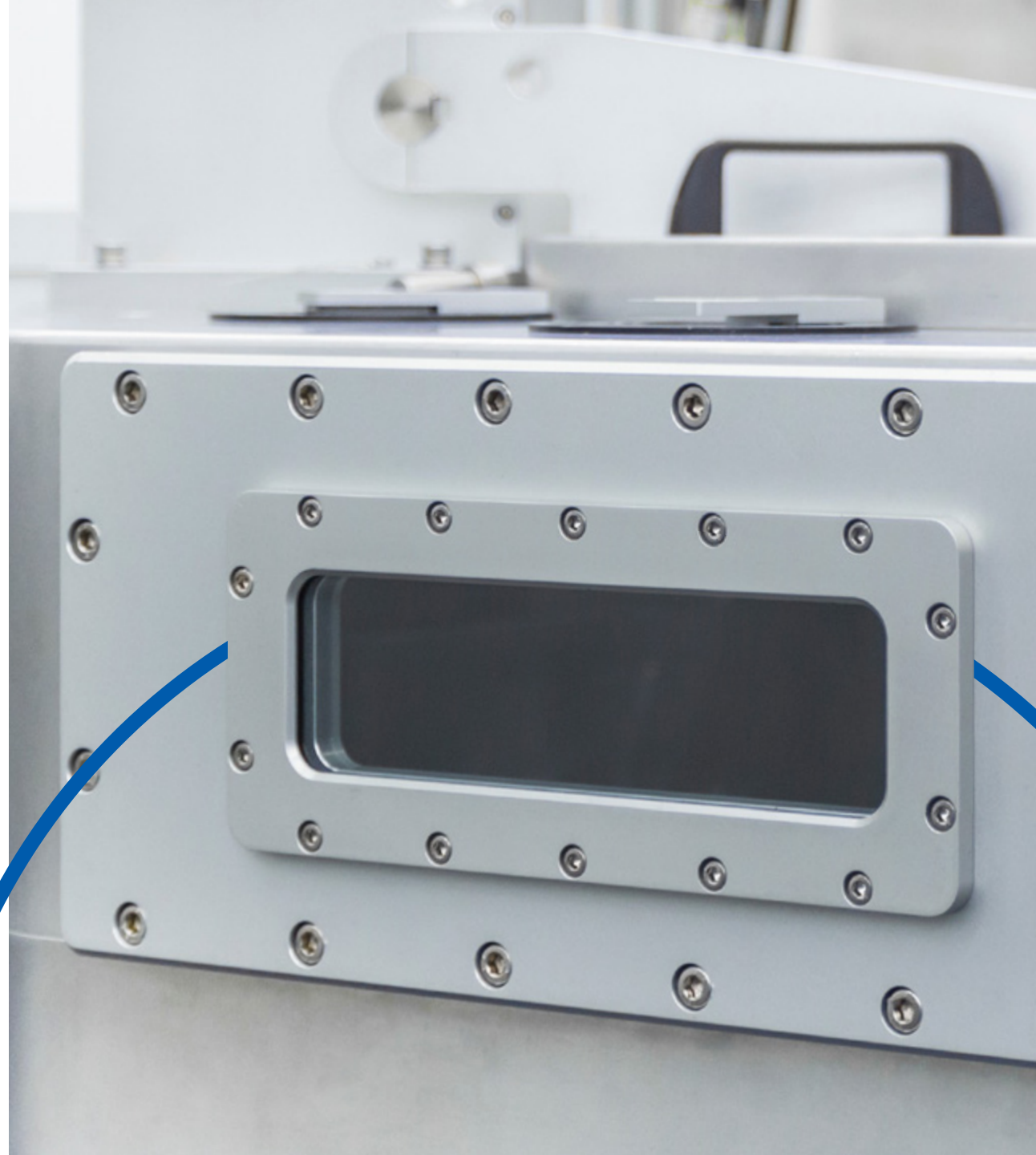




Semiconductor & Electronics

# Vacuum Chamber Solutions

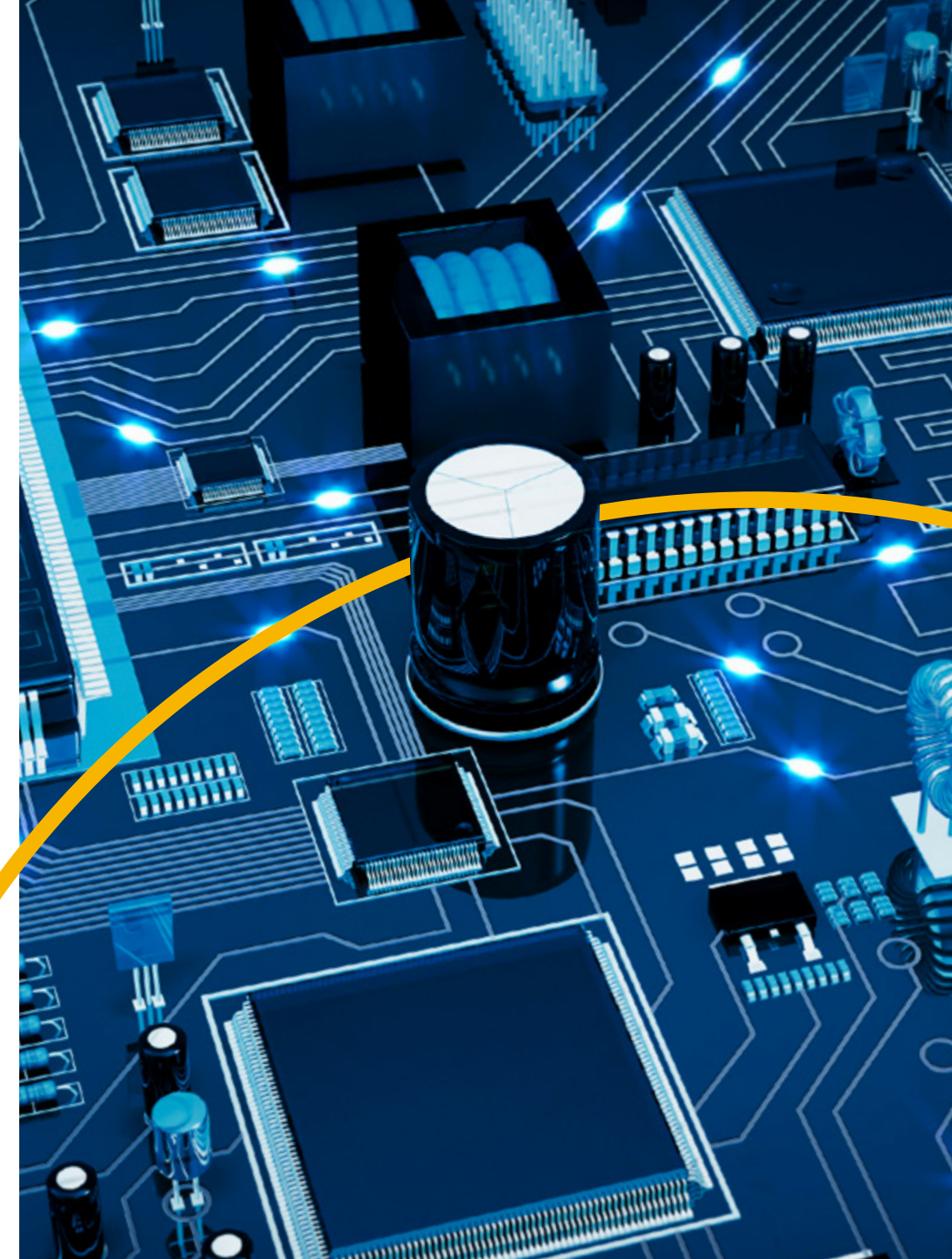
World's broadest portfolio of polymer solutions for use in vacuum chamber applications



# Typical process tools: Etch, CVD, PVD & ion implant

## Material Solutions & key properties

- **Ketron® 1000 PEEK**  
For use in lower power, lower heat (300°F) or indirect plasma chamber applications such as wafer mobility.
- **Duratron® T4203 PAI**  
For use in medium power, medium heat (500°F) applications or indirect chamber applications in presence of Oxygen plasma.
- **Duratron® CU60 PBI**  
For use in high power, high heat (750°F) applications or indirect chamber applications when in the presence of Oxygen plasma.
- **Semitron® MPR1000**  
For use in high power, medium heat (520°F) applications.  
Best in class when in presence of Oxygen plasma.



# General trends

## Key Considerations

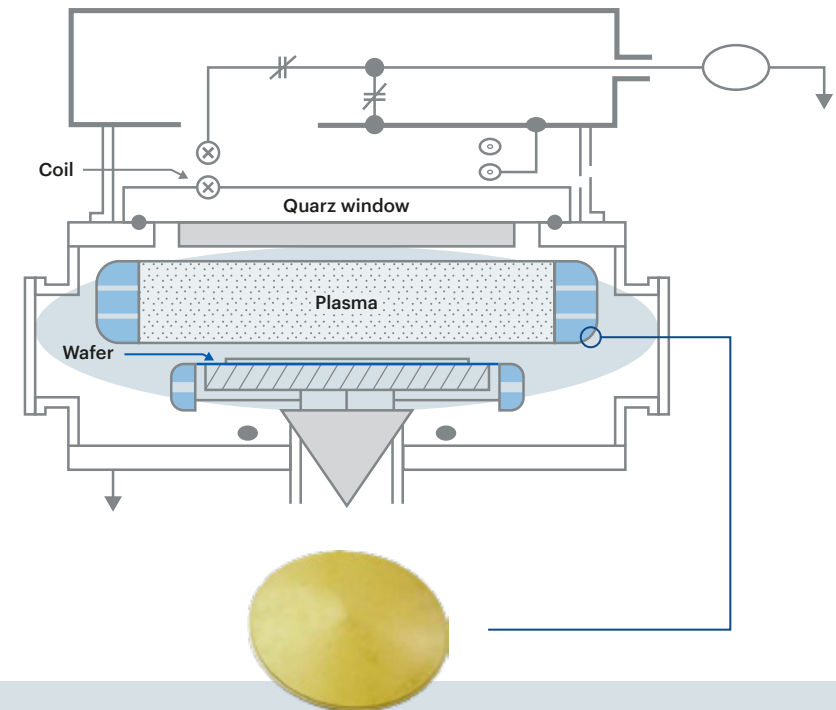
- Increasing energy in plasma chambers
- More aggressive plasma chemistries, introduction of Oxygen into the chambers
- Pinpoint material selection on a per application basis to maximize “cost vs. performance”
- Replacement of polyimide for reduced cost & increased performance
- Careful use of ceramics & quartz due to cost & breakage
- Increased requirements for ionic purity due to reduced node size

## Typical Applications

- Screws & pins
- Clamp & trench rings
- Valve housings
- Shower heads
- Various etch & CVD parts

## Competitive Quartz vs. Semitron® MPR-1000

Competitive Quartz is much more brittle than Semitron® MPR-1000 and is often chipping in vacuum chambers.



# Introducing Semitron® MPR1000

Semitron® MPR1000 was developed to provide engineers with a viable polymer-based option when confronted with the increasing demands in vacuum plasma based chamber design due to use of Oxygen to clean the chamber and the rapidly increasing electrode power.

## Product features

- Excellent plasma resistance in Oxygen plasma, approaches quartz
- 12-25X\* better than polyimide in Oxygen plasma
- Excellent chip resistance, durability & machinability compared to quartz
- Lowest overall cost of any polymer solution
- Excellent ionic purity



PEEK



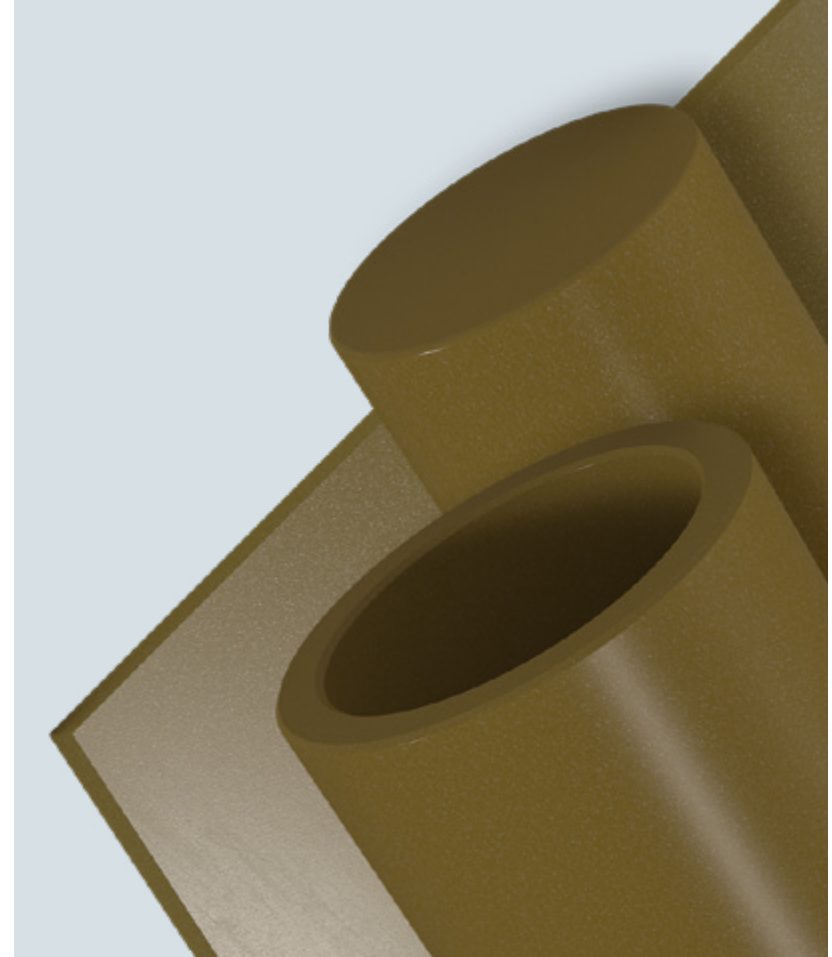
PAI



Polyimide



Semitron®  
MPR-1000



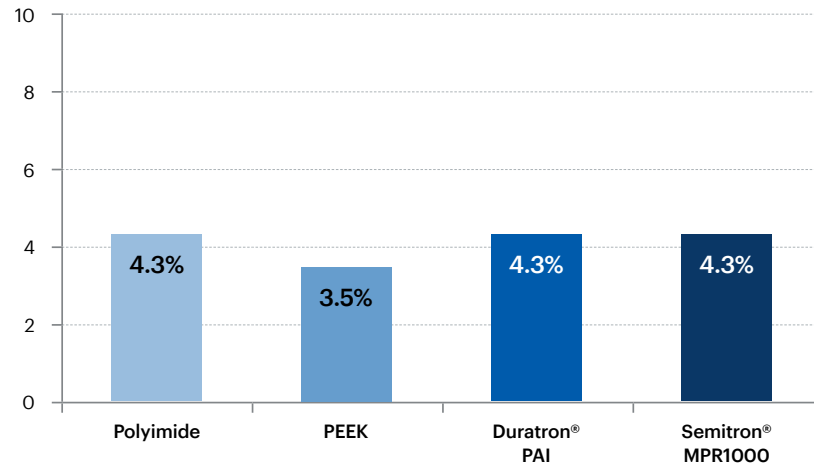


## Percent weight loss in Cf4 plasma - low energy

- Most advanced engineering plastics perform similar in freon plasma gases
- The mode of degradation is mechanical erosion, a function of surface hardness & type of solid, crystalline vs amorphous

### Chamber conditions

• 1KW • CF 1200 sccm • 0.32 Torr • 50 hours

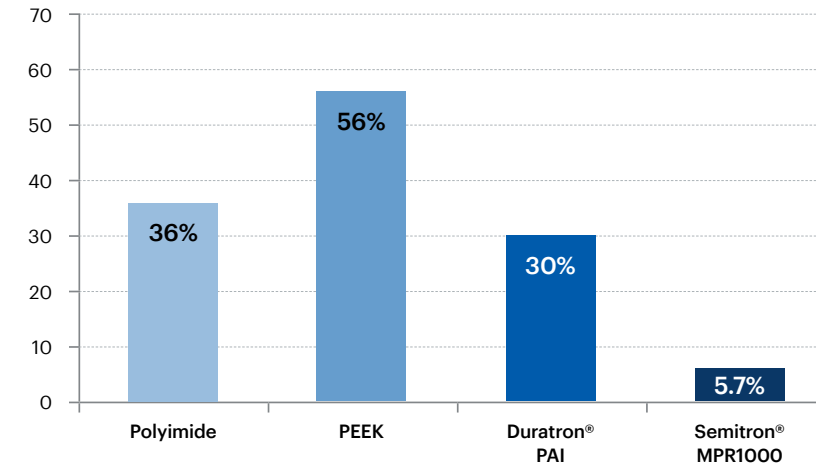


## Percent weight loss In O2 plasma - 2kw

- Advanced engineering plastics mode of degradation in Oxygen plasma is catastrophic oxidation
- Semitron® MPR1000 was developed to withstand the typical erosion experienced in Oxygen plasma chambers
- Semitron® MPR1000 displays 10X better results than PEEK and 6X better results than polyimide in a 2KW Oxygen plasma chamber and up to 25X better results than polyimide at 2.5KW Oxygen plasma

### Chamber conditions

• 2KW • O2 1200 sccm • 0.30 Torr • 50 hours • 13.56 MHz



Ionic purity data

|                    | Aluminum (Al) | Barium (Ba) | Calcium (Ca) | Chromium (Cr) | Copper (Cu) | Iron (Fe) | Lead (Pb) | Lithium (Li) | Magnesium (Mg) | Manganese (Mn) | Nickel (Ni) | Potassium (K) | Sodium (Na) | Strontium (Sr) | Titanium (Ti) | Zinc (Zn) |
|--------------------|---------------|-------------|--------------|---------------|-------------|-----------|-----------|--------------|----------------|----------------|-------------|---------------|-------------|----------------|---------------|-----------|
| Semitron® MPR1000  | 0.14          | 0.07        | 2.8          | 2.6           | 0.14        | 2.3       | 0         | 0            | 0.3            | 0.11           | 0.36        | 0.77          | 4.4         | 0.04           | 0.12          | 0         |
| Ketron® PEEK       | 0.38          | 0.02        | 8            | 0.49          | 0.2         | 6         | 0.005     | 0.005        | 0.8            | 0.2            | 0.42        | 1.6           | 480         | 0.06           | 0.18          | 0.15      |
| Standard Polyimide | 0.47          | 0.05        | 0.01         | 0.01          | 0.05        | 0.36      | 0.05      | 0.05         | 0.28           | 0.02           | 0.02        | 0.13          | 0.44        | 0.05           | 0.05          | 0.02      |
|                    |               |             |              |               |             |           |           |              |                |                |             |               |             |                |               |           |
| Semitron® MPR1000  | 0.14          | 0.07        | 2.8          | 2.6           | 0.14        | 2.3       | 0         | 0            | 0.3            | 0.11           | 0.36        | 0.77          | 4.4         | 0.04           | 0.12          | 0         |
| Standard Polyimide | 17.68         | 1.88        | 0.38         | 0.38          | 1.88        | 13.55     | 1.88      | 1.88         | 10.54          | 0.75           | 0.75        | 4.89          | 16.56       | 1.88           | 1.88          | 0.75      |

by total digestion

Adjusted for mass loss during erosion 2.5 KW • 2000 sccm • O2

# Material comparison guide

|   |                     | Standard Polyimide     | Duratron® CU60 PBI     | Ketron® 1000 PEEK      | Semitron® MPR1000      | Duratron® T4203 PAI    |
|---|---------------------|------------------------|------------------------|------------------------|------------------------|------------------------|
| Mechanical properties                   |                     |                        |                        |                        |                        |                        |
| Tensile strength (psi)                  | D638                | 12,500                 | 16,000                 | 16,000                 | 17,000                 | 20,000                 |
| Tensile modulus (psi)                   | D638                | -                      | 850,000                | 630,000                | 1,200,000              | 600,000                |
| Flexural strength (psi)                 | D790                | 16,000                 | 32,000                 | 25,000                 | 24,000                 | 24,000                 |
| Flexural modulus (psi)                  | D790                | 450,000                | 950,000                | 600,000                | 1,050,000              | 600,000                |
| Hardness rockwell                       | D785                | M82                    | M125                   | M100                   | M106                   | M120                   |
| Moisture absorption 24hrs @73°F (%)     | D570 <sup>(2)</sup> | 0.24                   | 0.40                   | 0.10                   | 0.28                   | 0.40                   |
| Moisture absorption @ saturation (%)    | D570 <sup>(2)</sup> | 1.5                    | 5.0                    | 0.5                    | 3.4                    | 1.7                    |
| Tribological properties                 |                     |                        |                        |                        |                        |                        |
| CLTE (in./in./°F)                       | E-831 (TMA)         | 3.0 x 10 <sup>-5</sup> | 1.3 x 10 <sup>-5</sup> | 2.6 x 10 <sup>-5</sup> | 1.5 x 10 <sup>-5</sup> | 1.7 x 10 <sup>-5</sup> |
| Heat deflection temperature @66psi (°F) | D648                | 632                    | 800                    | 320                    | 534                    | 532                    |
| Electrical properties                   |                     |                        |                        |                        |                        |                        |
| Dielectric constant @ 1 Hz              | D150                | 4.20                   | 3.20                   | 3.30                   | 3.68                   | 4.20                   |
| Dissipation factor @ 1 Hz               | D150                | 0.0034                 | 0.0030                 | 0.0030                 | 0.0080                 | 0.0260                 |
| Dielectric strength                     | D149                | 560                    | 550                    | 480                    | 570                    | 580                    |
| Ionic purity                            | -                   | Excellent              | Good                   | Fair                   | Excellent              | Good                   |

1) Data represents our estimated maximum long-term service temperature based on practical field experience. (2) Specimens: 1/8" thick x 2" diameter or square.

(3) Estimated rating based on available data. The UL-94 Test is a laboratory test and does not relate to actual fire hazard.

# Get in touch

## Contact.

[contact.mcam@mcgc.com](mailto:contact.mcam@mcgc.com)

## Visit.

[www.mcam.com/en/contact](http://www.mcam.com/en/contact)

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### Europe

Mitsubishi Chemical  
Advanced Materials NV  
Galgenveldstraat 12  
8700 Tielt,  
Belgium

**Tel: +32 51 42 35 11**

[www.mcam.com](http://www.mcam.com)

### North America

Mitsubishi Chemical  
Advanced Materials Inc.  
2120 Fairmont Avenue  
PO Box 14235 — Reading,  
PA 19612-4235

**Tel: +1 610 320 6600**

### Asia-Pacific

Mitsubishi Chemical  
Advanced Materials Asia Pacific Ltd.  
Unit 7B, 35/F, Cable TV Tower,  
9 Hoi Shing Road,  
Tsuen Wan, Hong Kong

**Tel: +852 2470 26 83**

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